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Application Number	10/756,122-Conf. #4554
Filing Date	January 13, 2004
First Named Inventor	Wai-Fan Yau
Art Unit	2823
Examiner Name	J. J. Maldonado
Attorney Docket Number	002592 C7/DSM/ OW K

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Examiner Signature		Date Considered	
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Substitute for form 1449/PTO		Complete if Known	
INFORMATION DISCLOSURE STATEMENT BY APPLICANT (Use as many sheets as necessary)		Application Number	10/756,122-Conf. #4554
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Sheet	2	of	2
		Attorney Docket Number	002592.C7/DSM/LOW K/JW

NON PATENT LITERATURE DOCUMENTS			
Examiner Initials	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T ²
	C1	K.H.A. BOGART, ET AL., "Plasma Enhanced Chemical Vapor Deposition of SiO ₂ Using Novel Alkoxysilane Precursors," J. Vac. Sci. Technol. A, Vol. 13, No. 2, Mar/Apr 1995, pages 475-480.	
	C2	A. KLUMP, "Photo Induced Transformation of Polysiloxane Layers to SiO ₂ ," Applied Surface Science, Volume 43 (1989), pages 301-303.	
	C3	The Board's Decision on Appeal mailed September 16, 2004, for Serial No. 09/477,126, filed December 30, 1999 (AMAT/2592.X1).	
	C4	The Board's Decision on Request for Rehearing mailed December 23, 2004, for Serial No. 09/477,126, filed December 30, 1999 (AMAT/2592.X1).	
	C5	WOLF, et al.; Silicon Processing for the VLSI Era, Volume 1; Process Technology, 1986 by Lattice Press, pp. 161-174.	
	C6	Prosecution History for U.S. Patent Application No. 11/877,483 filed October 23, 2007 (APPM/002592.C12)	

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